

DECLARATION FOR PATENT APPLICATION

As a below named inventor, I declare:

that I verily believe myself to be the original, first and sole (if only one individual inventor is listed below) or an original, first and joint inventor (if more than one individual inventor is listed below) of the invention in

METAL OXIDE SEMICONDUCTOR (MOS) TYPE SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

the specification of which is attached hereto unless the following box is checked.

☒ was filed on March 26, 2004 as United States Application or PCT International Application No. 10/811,107, and was amended on _____ (if applicable).

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information of which is material to patentability as defined in 37 CFR 1.56.

I hereby claim foreign priority benefits under 35 U.S.C. 119(a)-(d) or 365 (b) of any foreign application(s) for patent or inventor's certificate, or 35 U.S.C. 365(a) of any PCT International application which designated at least one country other than the United States, listed below and have also identified below any foreign application for patent or inventor's certificate, or PCT International application having a filing date before that of the application on which priority is claimed:

<u>Country</u>	<u>Category</u>	<u>Application No.</u>	<u>Filing Date</u>	<u>Priority Claim</u>
Japan	Patent	2003-399895	November 28, 2003	Yes

And I hereby appoint Barry N. Young (Reg. No. 27,774), Timothy W. Lohse (Reg. No. 35,255), David F. Keinsmith (Reg. No. 40,050), Stephen E. Reiter (Reg. No. 31,192), Wayne P. Sobon (Reg. No. 32,438), Robroy R. Fawcett (Reg. No. 35,133), Steven R. Sprinkle (Reg. No. 40,825), William N. Hulsey III (Reg. No. 33,402), Terrance A. Meador (Reg. No. 30,298), John Schlicher (Reg. No. 28,343), June M. Learn (Reg. No. 31,238), John Oskorep (Reg. No. 41,234), Timothy N. Ellis (Reg. No. 41,734), David R. Stevens (Reg. No. 38,626), William G. Goldman (Reg. No. 42,590), Derek Westberg (Reg. No. 40,872), Alan A. Limbach (Reg. No. 39,749), Edward B. Weller (Reg. No. 37,468), Ronald L. Yin (Reg. No. 27,607), and George C. Limbach (Reg. No. 19,305) each of whose address is 2000 University Circle, East Palo Alto, CA 94303-2248, or any one of them, my attorneys with full power of substitution and revocation, to prosecute this application and to transact all business in the Patent & Trademark Office connected therewith, and request that correspondence be directed to Gray Cary Ware & Freidenrich L.L.P., 2000 University Circle, East Palo Alto, CA 94303-2248.

I declare further that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of

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I declare further that my mailing address is at c/o
Intellectual Property Division, Toshiba Corporation, 1-1, Shibaura
1-chome, Minato-ku, Tokyo 105-8001, Japan; and
that my citizenship and residence are as stated below next to my name:

Inventor: (Signature)DateResidenceDate: MAY. 20. 2004Hironobu Fukui
Hironobu FukuiCitizen of: JapanKawasaki-shi, JapanDate:Citizen of: JapanDate:Citizen of: JapanDate:Citizen of: JapanDate:Citizen of: JapanDate:Citizen of: JapanDate:Citizen of: JapanDate:Citizen of: Japan